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35.C10499 CONT. I/DIV. I

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
HIDEAKI MITSUTAKE, ET AL ✓ ) : Examiner: A. Patel  
Application No.: 09/045,681 ✓ ) : Group Art Unit: 2875  
Filed: March 23, 1998 ✓ ) :  
For: ELECTRON BEAM APPARATUS ) : August 31, 1999  
AND IMAGE FORMING ✓ ) :  
APPARATUS ) :

The Assistant Commissioner for Patents  
Washington, D.C. 20231

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FIRST SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. §1.56 and in accordance with the practice under 37 C.F.R. §§1.97 and 1.98, the Examiner's attention is directed to the enclosed European Search Report that lists documents that were previously cited and enclosed in the Information Disclosure Statement of March 23, 1998.

Applicants certify under 37 C.F.R. §1.97(e)(1) that each item of information contained in the subject information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement. Specifically, the European Search Report is dated August 4, 1999.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

  
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Attorney for Applicants

Registration No. 32,533

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

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